

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	((("6409453") or ("5925227"))).PN.	US-PGPUB; USPAT	OR	OFF	2005/09/30 20:33
S7	1579	(118/719).CCLS.	US-PGPUB; USPAT	OR	OFF	2005/09/22 13:34
S8	6	S7 and ((wafer substrate) with (holder hand blade).ti.)	US-PGPUB; USPAT	OR	ON	2005/09/22 13:33
S9	6	S7 and ((wafer substrate) with (holder hand blade)).ti.	US-PGPUB; USPAT	OR	ON	2005/09/22 13:33
S10	4	("4089735" "4313254" "4358472" "4430149").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/22 14:07
S11	2	("4984954").URPN.	USPAT	OR	ON	2005/09/22 14:09
S12	26	("5239182").URPN.	USPAT	OR	ON	2005/09/22 14:10
S13	9	("4770590" "4803373" "5044752" "5239182" "5277539" "5409348" "5540098" "5563798" "5645391").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/22 14:35
S14	6	("3272350" "4002254" "4433951" "4542712" "4810473").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/22 14:59
S15	412	(204/298.15).CCLS.	US-PGPUB; USPAT	OR	OFF	2005/09/22 16:48
S16	2	("4880518").URPN.	USPAT	OR	ON	2005/09/22 15:11
S17	2	("4880518").URPN.	USPAT	OR	ON	2005/09/22 15:12
S18	6	("4473455" "4589369" "4595481" "4634512" "4650064" "4735701").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/22 15:12
S19	4	("4595481" "4650064" "5244555" "5296118").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/22 16:44
S20	0	("6528124").URPN.	USPAT	OR	ON	2005/09/22 16:45
S21	0	204/298.ccls. and (nickel with aluminum)	US-PGPUB; USPAT	OR	ON	2005/09/22 16:49
S22	213	204/298\$.ccls. and (nickel with aluminum)	US-PGPUB; USPAT	OR	ON	2005/09/22 16:49
S23	1	204/298\$.ccls. and (nickel with aluminum with friction)	US-PGPUB; USPAT	OR	ON	2005/09/22 16:50
S24	8	(substrate wafer semiconductor workpiece disc disk) with (hold\$3 susceptor hand robot blade carrier transfer\$4 transport\$4 spatula) with (nickel with aluminum with friction)	US-PGPUB; USPAT	OR	ON	2005/09/22 17:07
S25	1	("5750642").PN.	US-PGPUB; USPAT	OR	OFF	2005/09/22 16:57
S26	2	08/801,706	US-PGPUB; USPAT	OR	ON	2005/09/22 16:58
S27	3	09/801,706	US-PGPUB; USPAT	OR	ON	2005/09/22 16:58
S28	5	08/801,076	US-PGPUB; USPAT	OR	ON	2005/09/22 16:58
S29	32	(substrate wafer semiconductor workpiece disc disk) same (nickel with aluminum with (slip\$4 friction))	US-PGPUB; USPAT	OR	ON	2005/09/22 17:14
S30	14	(blade carrier holder hand) with (nickel with aluminum with (slip\$4 friction))	US-PGPUB; USPAT	OR	ON	2005/09/22 17:15
S31	332	(blade carrier holder hand) with (nickel with aluminum with (coat\$3 layer film))	US-PGPUB; USPAT	OR	ON	2005/09/22 17:15
S32	54620	(blade carrier holder hand) with (nickel with aluminum with (coat\$3 layer film) with (friction slip\$4))	US-PGPUB; USPAT	OR	ON	2005/09/22 17:15

S33	3	(blade carrier holder hand) with (nickel with aluminum with (coat\$3 layer film) with (friction slip\$4))	US-PGPUB; USPAT	OR	ON	2005/09/22 17:16
S34	2	(blade carrier holder hand robot ((transfer\$4 transport\$4 convey\$4) with (device mechanism))) with (nickel with aluminum with (coat\$3 layer film) with (friction slip\$4))	EPO; JPO; DERVENT	OR	ON	2005/09/22 17:17
S35	1141	(blade carrier holder hand robot ((transfer\$4 transport\$4 convey\$4) with (device mechanism))) same (nickel with aluminum with (coat\$3 layer film plat\$3))	US-PGPUB; USPAT	OR	ON	2005/09/22 18:05
S36	445	(blade carrier holder hand robot ((transfer\$4 transport\$4 convey\$4) with (device mechanism))) with (nickel with aluminum with (coat\$3 layer film plat\$3))	US-PGPUB; USPAT	OR	ON	2005/09/22 18:05
S37	158	(blade carrier holder hand robot ((transfer\$4 transport\$4 convey\$4) with (device mechanism))) with (nickel with aluminum with (plat\$3))	US-PGPUB; USPAT	OR	ON	2005/09/22 18:05
S38	34	(US-20030057089-\$ or US-20050092254-\$ or US-20030070316-\$).did. or (US-4885067-\$ or US-4934315-\$ or US-4984954-\$ or US-5239182-\$ or US-5740034-\$ or US-5768125-\$ or US-4770590-\$ or US-5645391-\$ or US-5044752-\$ or US-5563798-\$ or US-5906469-\$ or US-6043502-\$ or US-6236904-\$ or US-6287067-\$ or US-6522942-\$ or US-6900877-\$ or US-4512841-\$ or US-4793975-\$ or US-4880518-\$ or US-5244555-\$ or US-5925227-\$ or US-6013162-\$ or US-6528124-\$ or US-6783596-\$ or US-6155773-\$ or US-5955858-\$).did. or (US-6222337-\$ or US-6513848-\$ or US-6709218-\$ or US-4465524-\$).did. or (US-3272350-\$).did.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/22 18:06
S39	7	S38 and nickel	US-PGPUB; USPAT	OR	ON	2005/09/22 18:10
S40	9	414/941.ccls. and nickel	US-PGPUB; USPAT	OR	ON	2005/09/22 18:29
S41	60	414/941.ccls. and (sputter\$4 "pvd" "physical vapor deposition")	US-PGPUB; USPAT	OR	ON	2005/09/22 18:54
S42	1	("6409453").PN.	US-PGPUB; USPAT	OR	OFF	2005/09/23 13:34
S43	48	(US-20020192056-\$ or US-20030057089-\$ or US-20030070316-\$ or US-20030085582-\$ or US-20050092254-\$).did. or (US-4465524-\$ or US-4512841-\$ or US-4715764-\$ or US-4770590-\$ or US-4793975-\$ or US-4880518-\$ or US-4885067-\$ or US-4934315-\$ or US-4984954-\$ or US-5044752-\$ or US-5239182-\$ or US-5244555-\$ or US-5563798-\$ or US-5570994-\$ or US-5636964-\$ or US-5645391-\$ or US-5740034-\$ or US-5746460-\$ or US-5768125-\$ or US-5906469-\$ or US-5925227-\$ or US-5938902-\$ or US-5955858-\$ or US-5980194-\$ or US-6013162-\$ or US-6024393-\$).did. or (US-6043502-\$ or US-6155773-\$ or US-6187103-\$ or US-6222337-\$ or US-6236904-\$ or US-6238160-\$ or US-6267423-\$ or US-6287067-\$ or US-6409453-\$ or US-6513848-\$ or US-6522942-\$ or US-6528124-\$ or US-6709218-\$ or US-6752585-\$ or US-6783596-\$ or US-6900877-\$).did. or (US-3272350-\$).did.	US-PGPUB; USPAT; USOCR	OR	ON	2005/09/23 15:58
S44	2436	((sputter\$4 (physical with vapor with deposit\$3) "pvd") with aluminum) and electrostatic	US-PGPUB; USPAT	OR	ON	2005/09/23 15:59
S45	1	S43 and S44	US-PGPUB; USPAT	OR	ON	2005/09/23 17:00
S46	0	"davidson-mark.in"	US-PGPUB; USPAT	OR	ON	2005/09/23 17:00
S47	0	"davidson-mark-\$.in"	US-PGPUB; USPAT	OR	ON	2005/09/23 17:00